

ABOUT HERAEUS

The **Heraeus Group** is a broadly diversified and globally leading family-owned technology company, headquartered in Hanau, Germany.

The company's roots go back to a family pharmacy started in 1660. Today, **Heraeus** bundles diverse activities in the Business Platforms Metals and Recycling, Healthcare, Semiconductor and Electronics as well as Industrials. Customers benefit from innovative technologies and solutions based on broad materials expertise and technological leadership.

In the 2022 financial year, the group generated revenues of € 29.1 billion (US\$ 30.6 billion*) with approximately 17,200 employees in 40 countries. **Heraeus** is one of the top 10 family-owned companies in Germany and holds a leading position in its global markets.

*calculated with 2022 average exchange rate, 1€ = 1.0530 US)

ABOUT HERAEUS EPURIO LLC

Heraeus Epurio LLC is an award-winning specialty chemicals producer that develops Photo-Acid Generators (PAGs), Polymers, Monomers, and Crosslinkers for the semiconductor, display, electronic and aerospace industries.

We are experts in producing materials with **low trace metals**, while also having extensive experience in synthesizing a wide variety of organic compounds.

We provide quality customized service and are known in our industry as the reliable partner in development, from molecule to multi-tonne scale, to after-sales and technical support.

HERAEUS PHOTO-ACID GENERATORS

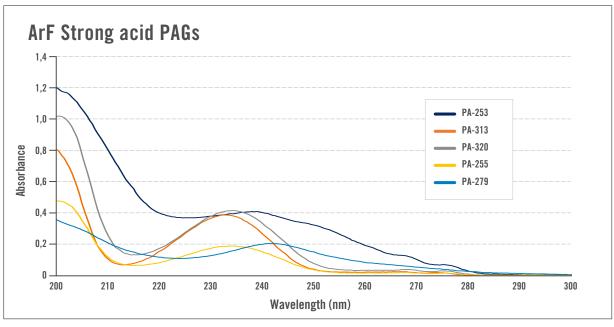
Heraeus Deep UV PAG

Based on 30 years of experience in producing electronic-grade photoactive materials as Daychem Laboratories in Dayton (OH), **Heraeus Epurio** has put together selected chromophores together with vintage acids to create different classes of advanced technology products for critical layer resists in high resolution.

Most of these products are available in ultra-pure (UP) quality with purity above 99.5% and content of all 26 metals below 10 ppb. This makes even conventional chemistry available for new frontiers in resist resolution.

Heraeus Ionic PAG Strong acid

Product Name	Chemical Structure	Properties	Features
PA-253		Strong acid generation m.p. 128-129°C	ArF
PA-313		Strong acid generation m.p. 129–130°C	ArF
PA-320	S^* $O = $	Strong acid generation m.p. 142–143°C	ArF
PA-255	F F F F SO ₃	Strong acid generation m.p. 93–95°C	ArF
PA-279		Strong acid generation m.p. 143–145°C	ArF



Ionic PAG

Heraeus Ionic PAG C1 acid

Product Name	Chemical Structure	Properties	Features
C TPS-C1	\$O ₂ CF ₃ F ₃ CO ₂ S ⊕ SO ₂ CF ₃	Strong acid(C1) generation m.p. 76–78°C	Deep UV
TTBPS-C1	SO ₂ CF ₃ F ₃ CO ₂ S $\stackrel{\bullet}{\bigcirc}$ SO ₂ CF ₃	Strong acid(C1) generation m.p. 164-165°C	Deep UV
DTBPIO-C1	\$O ₂ CF ₃ F ₃ CO ₂ S′ C SO ₂ CF ₃ → 1	Strong acid(C1) generation m.p. 104–105°C	Deep UV
PA-304	\$0 ₂ CF ₃ \$\frac{1}{5}\$C ₂ SO ₂ CF ₃	Strong acid(C1) generation m.p. 130–131°C	Deep UV

3 Commercialized product

Heraeus Ionic PAG - N3 acid

Product Name	Chemical Structure	Properties	Features
C TPS-N3	O ₂ S [*] N, SO ₂ F ₂ C, CF ₂	Strong acid(N3) generation m.p. 104–105°C	Deep UV
TDPS-N3	O ₂ \$ N \$O ₂ S F ₂ C CF ₂	Strong acid(N3) generation m.p. 83-85°C	Deep UV
TBPDPS-N3	O ₂ 5 ⁻ N ₅ O ₂ F ₂ C F ₂ CF ₂	Strong acid(N3) generation m.p. 114–116°C	Deep UV
TBPTMS-N3	$ \begin{array}{c} $	Strong acid(N3) generation m.p. 177–178°C	Deep UV
TTBPS-N3	O.S. N. SO ₂ F ₂ C. C. CF ₂ F ₂	Strong acid(N3) generation m.p. >240°C	Deep UV
PA-296	O ₂ S ^{-N} SO ₂ S ⁺ F ₂ C C ⁻ CF ₂ F ₂	Strong acid(N3) generation m.p. 159-161°C	Deep UV

Heraeus Ionic PAG - Nf acid

Product Name	Chemical Structure	Properties	Features
TPS-Nf	C ₄ F ₉ SO ₃ [⊖]	Low diffusion strong acid(nonaflic acid) generation m.p. 84–88°C	Deep UV
☼ TBPDPS-Nf	C ₄ F ₇ SO ₃	Low diffusion strong acid(nonaflic acid) generation m.p. 131–137°C	Deep UV
TBPTMS-Nf	\rightarrow S $C_4F_9SO_3^{\Theta}$	Low diffusion strong acid(nonaflic acid) generation m.p. 174–176°C	Deep UV
DTBPIO-Nf	$C_4F_9SO_3^{\bigodot}$ \downarrow	Low diffusion strong acid(nonaflic acid) generation m.p. 175–177°C	Deep UV

© Commercialized product

Heraeus Ionic PAG — other acids

Product Name	Chemical Structure	Properties	Features
TPS-TFMBS	CF ₃ SO ₃ ⊖	Weak acid (o-trifluoromethylbenzenesulfonic acid) generation m.p. 156–157°C	Deep UV
DTBPIO-TFMBS	CF ₃ SO ₃	Weak acid (o-trifluoromethylbenzenesulfonic acid) generation m.p. 162–164°C	Deep UV
DTBPIO-CS	→ → → → → → → → → → → → → → → → → → →	Weak acid (camphorsulfonic acid) generation m.p. 215–217°C	Deep UV

Heraeus Non-ionic DUV PAG

Product Name	Chemical Structure	Properties	Features
• MDT	N-O-S-CF ₃	White powder Strong acid (triflic acid) generation m.p. 88-89°C	Deep UV
PA-229	$\begin{array}{c} O \\ O \\ O \\ O \\ O \\ O \end{array}$	White powder Low diffusion strong acid (nonaflic acid) generation m.p. 54-56°C	Deep UV

HERAEUS I-LINE AND BROADBAND PAG

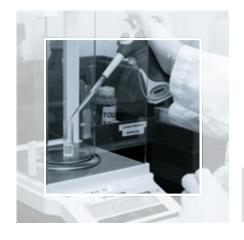
Following the growing market demand for highly sensitive, high solubility i-line PAG for various chemical amplified resist applications, **Heraeus Epurio** developed a set of I, h and g-line with the addition of broadband products.

Purity is according to the proven electronic grade quality of **Heraeus Epurio**, and most of the PAG's are scaled up cost-effectively in production to deliver up to ton quantities per year, making them also attractive for semiconductor Packaging and Display resists.

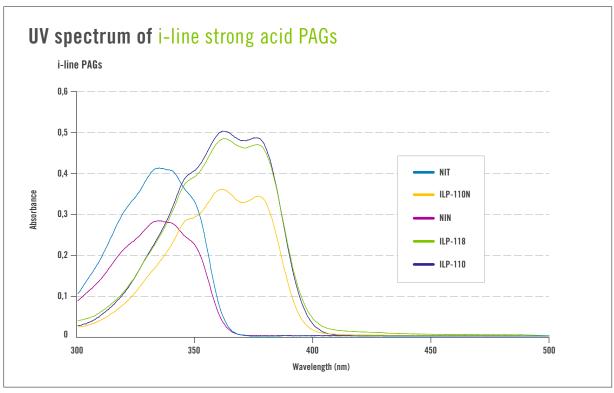
Heraeus Standard i-line strong acid PAGs

Product Name	Chemical Structure	Properties	Features
3 NIT	N-O-S-CF ₃	White powder Strong acid(triflic acid) generation m.p. 210–214°C	i-line
3 NIN	N-0-8 F F F F F F F F F F F F F F F F F F F	White crystalline powder. Low diffusion Strong acid(nonaflic acid) generation m.p. 148.5–149.5°C	i-line
ILP-110	0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0	Light-yellow powder Strong acid(triflic acid) generation m.p. 113-114°C	i-line
○ ILP-110N	N-O-S F F F F F F F F F F F F F F F F F F F	Low diffusion strong acid (nonaflic acid) generation m.p. 122–124°C	i-line
ILP-118	0 0 N-0-\$-CF ₃	Light-yellow powder Strong acid(triflic acid) generation m.p. 66–68°C	i-line

3 Commercialized product



NON-ionic PAG



* Sample concentration: 0.001% in MeCN

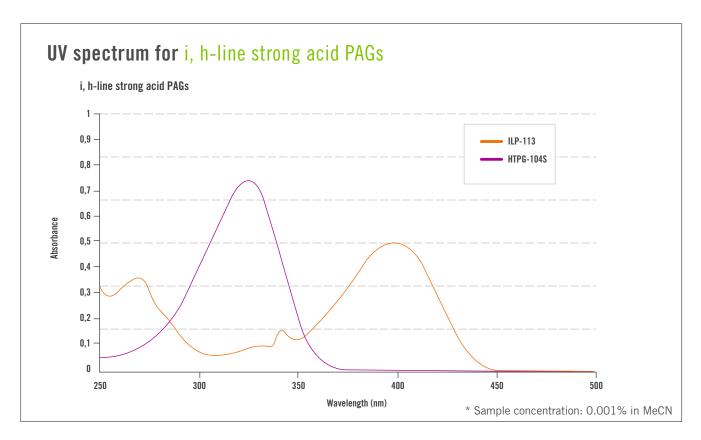
Heraeus i, h-line strong acid PAGs

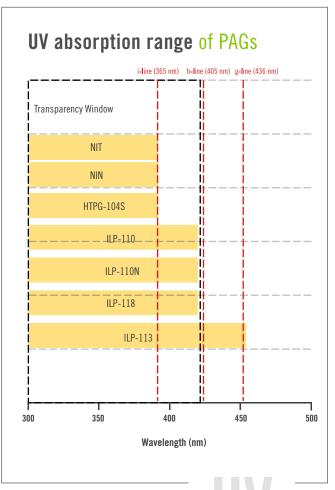
Product Name	Chemical Structure	Properties	Features	
ILP-113	S—————————————————————————————————————	Yellow powder Strong acid (triflic acid) generation m.p. 125–126°C	i, h-line broadband	
○ HTPG-104S	$MeO - \begin{picture}(20,20) \put(0,0){\line(1,0){100}} \put(0,0){\line(1$	White powder Strong acid (HCI) generation m.p. 143-145°C	i-line	

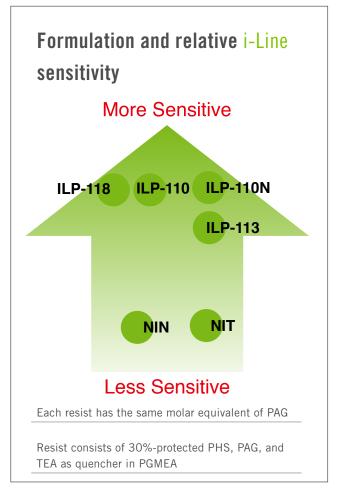
3 Commercialized product

I-line PAG

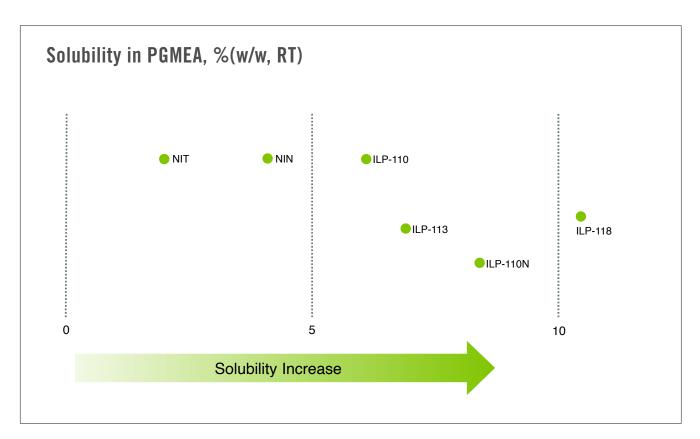
PAG

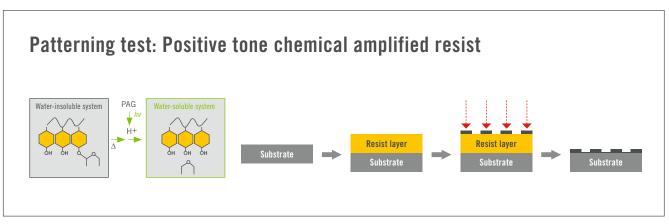


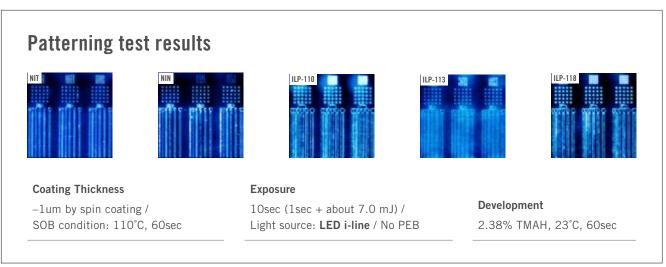




SOLUBILITY







Weak Acid

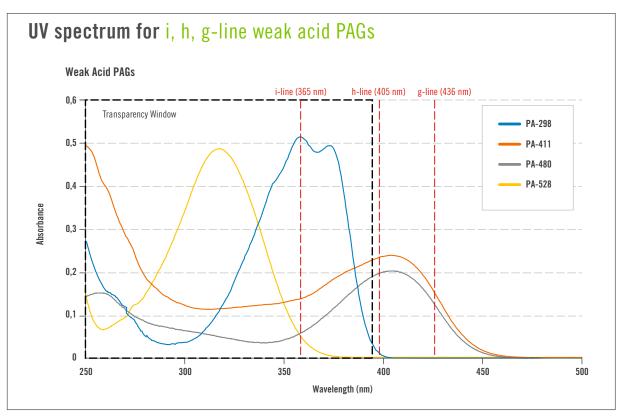
Heraeus i, h, g-line weak acid PAG

According to the market demand of weak acids for sensitive resin systems, **Heraeus Epurio** offers proven sensitive chromophore-weak acid combinations as cost effective alternatives to existing systems.

Excellent purity and quality consistency is a given also for this product range.

Heraeus i, h, g-line weak acid PAGs

Product Name	Chemical Structure	Properties	Features
PA-480	Yellow powder Weak acid(sulfonic acid) generation m.p. 143–145°C		i, h, g-line
PA-411	S O U	Yellow powder Weak acid(tosylic acid) generation m.p. 136–139°C	i, h, g-line
PA-298	\ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \	Yellow powder Weak acid(tosylic acid) generation m.p. 130–131°C	i-line
PA-528	MeO (N-O-S) (N	White powder Weak acid(tosylic acid) generation m.p. 134°C	i-line



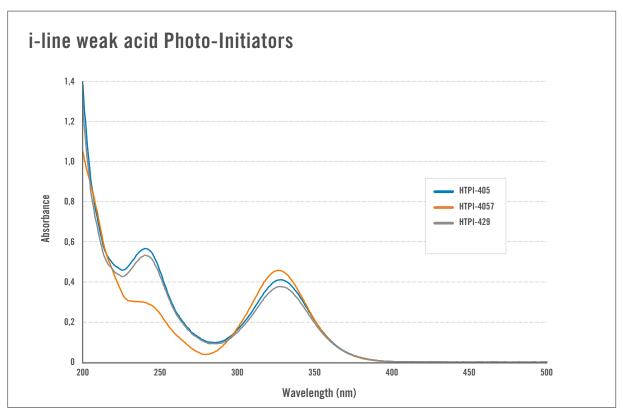
HERAEUS PHOTO-INITIATORS

Heraeus Epurio produces highly sensitive, thermostable and color-neutral photo-initiators with excellent solubility in standard resist solvents. These photo-initiators are qualified by major

resist producers and offer a cost-effective solution to display resist and semiconductor packaging resist formulations.

Heraeus I-Line — weak acid Photo-Initiators

Product Name	Chemical Structure	Properties	Features
HTPI-405		Weak acid generation m.p. 86–88°C	i-line
HTPI-4057		Weak acid generation m.p. 56–58°C	i-line
HTPI-429		Weak acid generation m.p. 71–74°C	i-line



* Sample concentration: 0.001% in MeCN

HERAEUS CROSSLINKERS

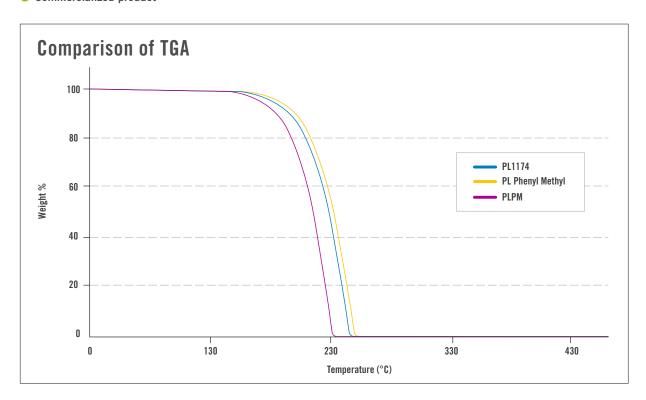
Heraeus Epurio has a long tradition of manufacturing glycoluril-based crosslinkers in highest purity for semicon resists. This is why processes have been developed and scaled up to reduce or remove contaminations of formaldehyde and methylene chloride

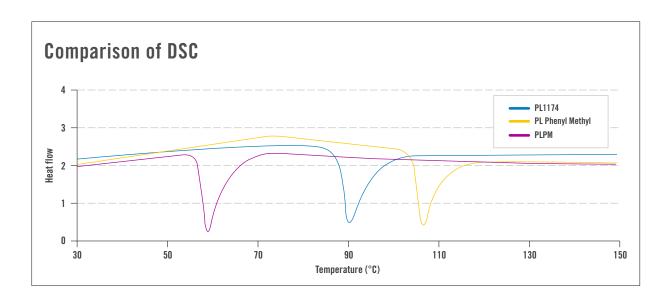
Today the low-metal contamination and the methylene chloride-free (MCF) products from

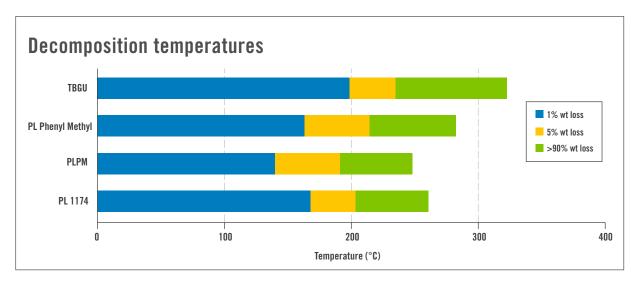
Heraeus Epurio define the new standard in the semiconductor industry. Various chemical modifications have significantly lowered the sublimation tendency.

Furthermore, **Heraeus Epurio** developed certified methylene chloride-free versions of crosslinkers to comply with international regulations against hazardous, halogenated materials, and to provide safe and environmentally-friendly products.

Product Name	Chemical Structure	Properties	Features
③ PL-1174		White crystalline powder m.p. 107-113°C Available methylene chloride-free (MCF) and UP	(F)
♡ TBGU		Colorless liquid Available methylene chloride-free (MCF) and UP	
₿ PLPM		White powder m.p. 87–89°C Available methylene chloride-free (MCF) and UP	Ø
PL Phenyl Methyl	Ph N	White powder m.p. 136-138°C Available methylene chloride-free (MCF) and UP	Ø







Solubility for crosslinkers

Solubility into 100 mL of	PLPM (-MCF)	PL Phenyl Methyl	PL1174	TBGU a
Water	7.7 g	<0.3 g	11.8 g	–6 g
Methanol	46 g	3.4 g	22.6 g	miscible
IPA	10 g	<2 g	<2 g	miscible
EL	25 g	<2 g	6 g	miscible
PGMEA	10 g	<2 g	<2 g	miscible
PGME	10 g	<2 g	<2 g	miscible

HERAEUS MONOMERS: ACRYLATE

With long experience of critical layer polyacrylatebased resists, **Heraeus Epurio** developed and scaled up a number of monomers with sterically hindered groups. From UP grade for new critical layer developments to high-end memory and logic chips-related photo materials such as PR, BARC, and hardmask applications, where cost and volume availability are important factors, we offer the entire product range.

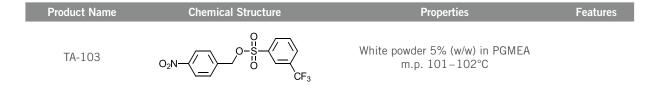
Product Name	Chemical Structure	Properties	Features
• MNLMA		White powder m.p. 74~77°C	Multi-layer photo-litho- graphic application
MAdMA	John State of the	Colourless liquid	Multi-layer photo-litho- graphic application
ECHA	Colourless liquid		Multi-layer photo-litho- graphic application
9-AMM		Yellow powder m.p. 86-88°C	Multi-layer photo-litho- graphic application
HAdMA	HO	White powder m.p. 89-91°C	Multi-layer photo-litho- graphic application

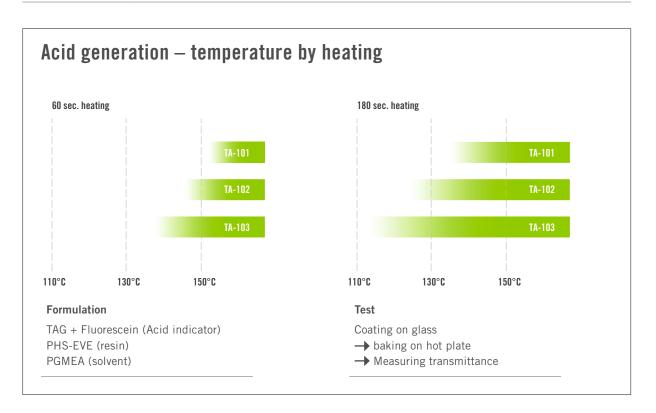
HERAEUS THERMAL ACID GENERATORS

With thicker film resist demands, more and more formulations contain thermal acid generators to enable final curing during post-baking.

An IP-free set of products with different acid-releasing temperatures is available from **Heraeus Epurio**. Semiconductor-grade purity and effective costs are mandatory in the final application.

Product Name	Chemical Structure	Properties	Features
③ TA-101	O ₂ N-\(\sigma\) O-\(\sigma\) O-\(\sigma\)	White powder 4.5% (w/w) in PGMEA m.p. 101-102°C	
TA-102	O_2N O_3 O_3 O_3 O_3 O_3 O_3 O_3 O_3 O_3 O_4 O_5	White powder 2.5% (w/w) in PGMEA m.p. 126-127°C	





HERAEUS POLYIMIDE PRECURSORS

Heraeus Epurio can toll manufacture polyamic acids and other PI precursors to suit your needs. We have the capacity to produce an output of 2 tons per day,

and can safely handle all major solvents, diamines, and dianhydrides.

Product Name	Chemical Structure	Properties	Features
Polyamic acids (PAA) for Polyimides	HO O H Ar HO O O O O O O O O O O O O O O O O O O	High dielectric stability at high temperatures, chemically resistant and can be made colorless	Used as coatings in flex circuits, display, battery applications, photovoltaic and anywhere PI films are needed
PMR (Polymerizable Monomeric Reactants) Resins	Various diamine dianhydride mixtures	Used in temperatures over 350°C	Used in composites for high-temperature aerospace applications

Heraeus Epurio provides all kinds of chemical compounds based on the customer's requirements, using our high-level synthesis technology and long experience in electronic materials. Rapid and smooth transition from g-scale to kg-scale is provided. Please get in touch with our sales team.

Purification technology

High-end photoresist applications in semiconductors require super-low chemical impurity and metal ions content. Heraeus Epurio has begun producing ultra-purification-grade products for advanced semiconductor photoresists. Our new production facility, equipped with full clean room environment, has been fully operational since 2021.



Headquarters: Hanau, Germany Production: Dayton, Ohio, USA

Sales offices:

Heraeus Materials Technology Taiwan Ltd., Taipei, Greater China

Heraeus Electronic Chemicals (Shanghai) Co., Ltd., Shanghai, Greater China

Heraeus Korea, Suwon, South Korea

Heraeus K.K., Tokyo, Japan

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